

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Toshio TANAKA et al.

Serial No.: 10/774,690

Filed: February 10, 2004

For: PLASMA REACTOR AND PURIFICATION EQUIPMENT

## INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner of Patents Washington, DC 20231

Sir:

In accordance with MPEP 609 and 37 C.F.R. §§ 1.56, 1.97 and 1.98, Applicants bring the attached references to the Examiner's attention and request that they be considered and made of record in this application. Also attached is a completed PTO-1449 form. This Information Disclosure Statement is being filed within three (3) months of the filing date of this application. Thus, no fee is believed to be due for this Information Disclosure

Statement. However, the Commissioner is authorized to charge any fees associated with this communication or credit any overpayment to Deposit Account No. 50-1836. A duplicate copy of this Statement is enclosed for that purpose.

Prompt examination on the merits is respectfully requested.

Respectfully submitted

David L. Tarnoff Reg. No. 32,383

SHINJYU GLOBAL IP COUNSELORS, LLP 1233 Twentieth Street, NW, Suite 700 Washington, DC 20036 (202)-293-0444

Dated: 4-9-04 G:\03-MAR04-ELT\DK-US045031 IDS.doc

Approved for use through 10/31/2002. OMB 0651-0031

Substitute for form 1449A/PTO			Complete if Known		
			Application Number	10/774,690	
INFO	RMATION DI	SCLOSURE	Filing Date	02/10/04	
STA	TEMENT BY	APPLICANT	First Named Inventor	Toshio TANAKA	
			Group Art Unit		
	(use as many sheets	as necessary)	Examiner Name		
Sheet	1 0	1	Attorney Docket Number	DK-US045031	

U.S. PATENT DOCUMENTS  U.S. Patent Document  Examiner  Cite No. Patent Document  Name of Patentee or Applicant  Of Cited Document  Of Cited Document  Of Cited Document						
Examiner Initials *	Cite No.	U.S. Patent Document		Name of Patentee or Applicant	Date of Publication of Cited Document	
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FOREIGN PATENT DOCUMENTS							
Examiner Initials*	Cite No.	Foreign Patent Document			Name of Patentee or Applicant of	Date of Publication of Cited Document	Translation
		Office	Number	Kind Code (if known)	Cited Document	MM-YYYY	(Yes or No or N/A)
		JP	8-155249		Hitachi Zosen Corp.	06-1996	YES
		JP	9-869		Mitsubishi Heavy Industries, Ltd.	01-1997	YES
		JP	2003-38932		Daikin Industries, Ltd.	02-2003	YES
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Examiner Signature	Date Considered	

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Burden Hour Statement: This form is estimated to take 2.0 hours to complete. Time will vary depending upon the needs of the individual case. Any comments on the amount of time you are required to complete this form should be sent to the Chief Information Officer, U.S. Patent and Trademark Office,